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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**OFFICIAL****In re: Armbrust et al****Examiner: D. Kang****Serial No.: 09/666,325****Group Art Unit: 2811****Filing Date: September 21, 2000****Title: Self-Aligned Copper Silicide Formation
For Improved Adhesion/Electromigration****Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450****REPLY AND AMENDMENT
UNDER 37 C.F.R. §1.11**

In reply to the Office Action mailed December 29, 2003, Applicants respectfully request reconsideration of the outstanding rejections and reexamination of the present application in light of the following remarks and amendments.

CERTIFICATE OF TRANSMISSION UNDER 37 CFR 1.8

I certify that this correspondence of 8 pages is being transmitted by facsimile to the United States Patent and Trademark Office to: Examiner **D. Kang**, Art Unit **2811** at facsimile number **703 872-9306** on **March 23, 2004** by Arnette Dodge


(Signature of person transmitting paper)

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